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**FEB 14 2005**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: MASUDA et al  
Serial No.: 10/647,319  
Filed: August 26, 2003  
For: Plasma Etching Apparatus  
Art Unit: 1763  
Examiner: L. Alejandro Mulero

**AMENDMENT**

Mail Stop: Amendment (Fee)  
Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

February 14, 2005

Sir:

The following amendments and remarks which accompany the RCE are respectfully submitted in connection with the above-identified application, in response to the Office Action dated September 14, 2004. The amendments are listed below and set forth on the following pages.

Amendments to the Claims; and

Remarks are included following the amendments.